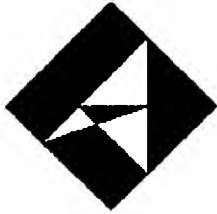


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**To:** Examiner Erik J. Kielin **Fax:** 703-872-9306  
**From:** Mag Chappuis **Date:** February 4, 2004  
**E-mail:** Mchappuis@atmi.com **Pages:** 11 (including transmittal)  
**Re:** Response to August 15, 2003 Office Action in U. S. Patent Application No. 09/823,196 **cc:**

**OFFICIAL COMMUNICATION**

**RESPONSE TO AUGUST 15, 2003 OFFICE ACTION IN UNITED STATES PATENT  
APPLICATION NO. 09/823,196 AND  
PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136**

Dear Examiner Kielin:

Please find the following documents enclosed:

Response to August 15, 2003 Office Action - 10 sheets  
Transmittal - 1 sheet

Please call 203-739-1435 if there are any problems with this transmittal.

Maggie Chappuis

ATMI, Inc.  
7 Commerce Drive  
Danbury, CT 06810  
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203-797-2544 (facsimile)  
ATMI Docket: ATM-S10

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U.S. Patent Application No. 09/823,196

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE****RECEIVED  
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**In re United States Patent Application of:****Applicants:** Thomas H. Baum et al.**Serial No.:** 09/823,196**Date Filed:** March 30, 2001**Title:** SOURCE REAGENT COMPOSITIONS  
FOR CVD FORMATION OF GATE  
DIELECTRIC THIN FILMS USING  
AMIDE PRECURSORS AND METHOD  
OF USING SAME**Docket No.:** ATMI-510**Examiner:** Erik J. Kiellin**Art Unit:** 2813**Customer No.:** 25559**OFFICIAL****FACSIMILE TRANSMISSION CERTIFICATE**

It hereby is certified by the person identified below that this paper is being facsimile transmitted by such person to the Commissioner of Patents and Trademarks on the date specified, to the Assistant Commissioner for Patents, Washington, DC 20231, and Transmitted by Facsimile under the provisions of 37 CFR 1.6(d).

  
Maggie S. HoppusFebruary 4, 2004  
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Facsimile Number**RESPONSE TO AUGUST 15, 2003 OFFICE ACTION IN UNITED STATES PATENT  
APPLICATION NO. 09/823,196 AND  
PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated August 15, 2003, applicant respectfully requests entry of the following Amendments and consideration of the subsequent remarks.